

Search Notes

Application/Control No.

10/628,494

Examiner

Steven D. Maki

Applicant(s)/Patent under
Reexamination

HIRAI, SATOSHI

Art Unit

1733

SEARCHED

Class	Subclass	Date	Examiner
152	209.2		
	209.18		
	209.28		
	902		
updated	above	11/19/2005	<i>SDM</i>

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
PGPUB, USPAT text search - see interference search printout		11/19/2005	<i>SDM</i>

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	11/19/2005	<i>SDM</i>